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Preliminary experiments on planma heating above lower hybrid renonance at frequency f $\simeq 2f_{LH}$ have been carried out in tokanak device TM-1-MH. For toroidal magnetic field 1.3T, the frequency 1.25 GHz and HP power 40 kW the increase of ion temperature of plasma up to $\Delta T_1/T_1^{OH} \approx 1$ was measured. The ion heating increases with the plasma density and a threshold character on incident HF power is observed. This HF heating is accompanied by changes in loop voltage and electron plasma

Recently a considerably progress in the LHR heating of tokamak plasma was achieved [1-4]. In the following results of the heating experiments at f = 2f_LH in TM-1-MH device are given.

The parameters of the TM-1-MH device are as follows: R = 0.4 m, limiter a=0.075 m, maximum toroidal magnetic field B,= 1.5 T, plasma current Ip up to 30 kA, loop voltage U_{loop} = 2-4V. Sche-matic arrangement of diagnostics and a position of the HF coupling element is shown in Fig. 1. A quasistationary state of the plasma discharge is reached after about 2 ms, while the total discharge length is 8 ms, see pulse gas filling Fig. 2a. Working gas is hydrogen at initial filling pressure usually 2x10-2Pa. To control the electron density, the additional

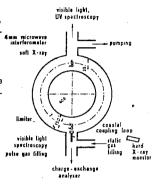
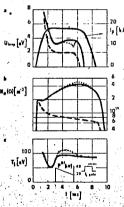


FIG. 1

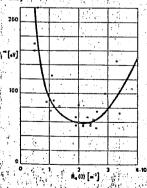
pulse hydrogen gas injection by means of the piezo-electric valve is used. The effect of this additional gas injection on plasma parameters is demonstrated in Figs. 2a,b, where time dependences without the injection are given as well (dashed lines). It may be seen that while the plasma current does not

change at all and the loop voltage is only slight increasing, the electron density can be increased remarkably. The magnitude of the electron density strongly influences the ion temperature (measured by 5-channel charge-exchange analyzer [6]) of the ohmically heated plasma Ti, see Fig. 3. Maximum value of the density on the axis Na(0), given in Fig. 3, was evaluated under assumption of the parabolic density distribution, from the line averaged density measured by the 4 mm interferometer.



PIG. 2

Heating experiments at f = $2f_{LH}$ were performed under following conditions: toroidal magnetic field $B_t = 1.3$ T, plasma current $I_p = 17$ kA line-averaged electron density $N_a = (0.5-2.5) \times 10^{19} \text{m}^{-3}$, ion temperature of the ohmically heated plasma on the exis T_(0)= =50-150 eV and electron tempe- 1, [av] rature on the axis T (0) = 300-:CC eV (estimated from conductivity measurements. UV radiacion of impurities and recenty from soft X-rays as well).



As a HF oscillator the CW magnetron (f=1,25GHz, F=45kW) was used. It was operated in A the pulse regime: maximum outout power 50 km; pulse length 3 na. output power drops during

FIG. 6 observed for powers greater than 20 kW only. The data given in Fig. 5 were obtained from spectra of charge-exchange neutrals displayed in Fig. 6. The spectra were measured in the 1 ms time gate (4-5th ms). The threshold character of HF heating is now under study. tion of the coupling loops on the heating efficiency. Authors are gratefull to Dr. Klima for stimulating discus-

the stationary value, see Pig. 2. All changes caused by the Ti power are shown in Fig. 2 by dotted lines. For HF power of 40 kW (at the beginning of pulse) the ion temperature measured by charge-exchange increases by 25% (see Fig. 2a). The bulk of ions is not heated, but as most probably a few tens percent of the total ion number only. Fig. 2a shows the effect of the HF power on the loop voltage. This voltage decreases by factor 10-20%. It corresponds to the electron temporature increase by 7-15%. The beginning of the loop voltage decrease is retarded by about 0.5-1.0 ms with regard to the beginning of the HF pulse. After HF pulse the voltage returns to the starting value quickly. The presence of HF power results in the moderate increase of the electron density by about 10% (see Fig. 2b).

this pulse to about 50% of maximum value. He power to fee to

the device through the ferrite isolator, calibrated directional couplers and impedance matcher. As a launching element of

coaxial coupling loop is used. The HF power is switched on i:

the third mo after the beginning of the plasma pulse that is

in the moment, when the plasma current and loop voltage achies:

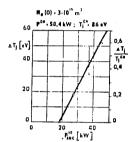


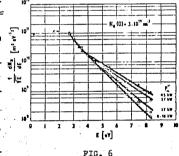
FIG. 5

FIG. 4

the ion temperature AT,/T, shown in Fig. 4 in dependence on the plasma density for HF power 25 kW. For densities N_e(0) smaller than lx10¹⁹m⁻³ practically no heating is observed. Considerable he-

The relative increase of

ating takes place at ND= = 2x10¹⁹m⁻³ when nearly 90% of incident power is delivered to the device (see measured power ref- # | w lection coefficient R2).



Very important is also dependence, of ion temperature increase on the HF power, see Fig.5. This dependence has a threshold character. Measurable HF heating is

It is not clear to us, if the ion heating in our experiments with additional gas injection is caused by the plasma density increase or by more efficient coupling due to change in plasma density profile. Our next experiments will be devoted to the detailed study of the influence of form and posi-

sions .

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